

INFORMATION DISCLOSURE STATEMENT BY APPLICANT <small>(Not for submission under 37 CFR 1.99)</small>	Application Number		10602468
	Filing Date		2003-06-23
	First Named Inventor		Venkat Selvamanickam
	Art Unit		1784
	Examiner Name		Aaron Austin
	Attorney Docket Number		1014-SP156-US

U.S.PATENTS						
Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
	1	6596085	B1	2003-07-22	Schmitt et al.	Corresponds to KR2001-78241.

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	1	20020009868	A1	2002-01-24	Tobashi et al.	Corresponds to KR2001-111027.

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FOREIGN PATENT DOCUMENTS

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	1	2001-78241	KR		2001-08-20	Applied Materials, Inc.	Corresponds to US 6596085.	<input type="checkbox"/>
	2	2001-111027	KR		2001-12-15	Toshiba Ceramics Co.	Corresponds to US 20020009868.	<input type="checkbox"/>
	3	11-329116	JP	A	1999-11-30	Fujikama Ltd.		<input checked="" type="checkbox"/>

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	4	2000-266667	JP		2000-09-29	Fuji Photo Film Co, Ltd.	w/English Abstract	<input type="checkbox"/>
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